

| | | | |
|---|--------------------------------------|-------------------------------------|--|
| Examiner-Initiated Interview Summary | Application No. 10/582,010 | Applicant(s) RATKE ET AL. | |
| | Examiner Chun-Cheng Wang | Art Unit 1796 | |

All Participants:

(1) Chun-Cheng Wang.

(2) Robert Siminski.

Date of Interview: 14 June 2010

Status of Application: Allowed

(3) _____.

(4) _____.

Time: 09:40 AM

Type of Interview:

☒ Telephonic

☐ Video Conference

☐ Personal (Copy given to: ☐ Applicant ☐ Applicant's representative)

Exhibit Shown or Demonstrated: ☐ Yes ☒ No

If Yes, provide a brief description: _____.

Part I.

Rejection(s) discussed:

Claims discussed:

1 and 7

Prior art documents discussed:

Part II.

SUBSTANCE OF INTERVIEW DESCRIBING THE GENERAL NATURE OF WHAT WAS DISCUSSED:

See Examiner's amendment

Part III.

☒ It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview directly resulted in the allowance of the application. The examiner will provide a written summary of the substance of the interview in the Notice of Allowability.

☐ It is not necessary for applicant to provide a separate record of the substance of the interview, since the interview did not result in resolution of all issues. A brief summary by the examiner appears in Part II above.

/Ling-Siu Choi/
Primary Examiner, Art Unit 1796

/Chun-Cheng Wang/
Examiner, Art Unit 1796

(Applicant/Applicant's Representative Signature – if appropriate)

U.S. Patent and Trademark Office
PTOL-413B (04-03)

Examiner Initiated Interview Summary

Paper No. 20100614